

**Notice of References Cited**

Application/Control No.

10/532,852

Applicant(s)/Patent Under

Reexamination

MAKI ET AL.

Examiner

RYAN D. WALSH

Art Unit

2852

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0085864	07-2002	Abe, Nobumasa	399/299
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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**FOREIGN PATENT DOCUMENTS**

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